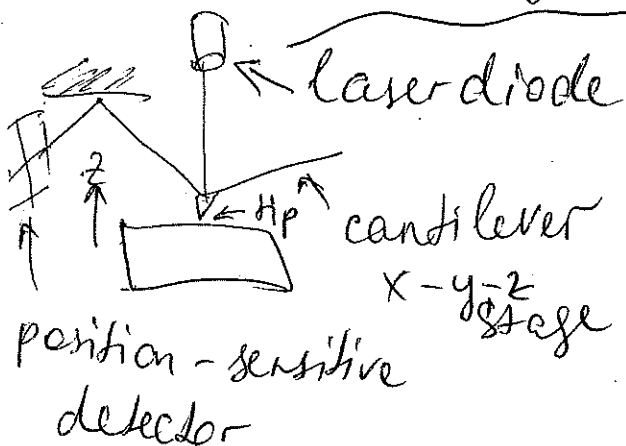


Lecture # 11

Atomic force microscopy

Typical cantilever:

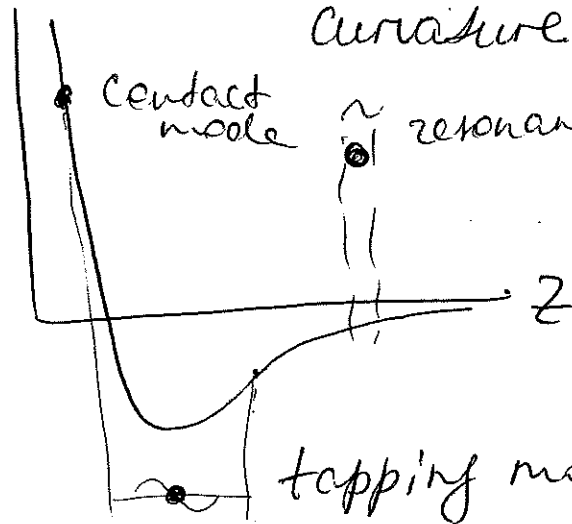
- rectangular or V-shaped
- 50-250 μm length
- 0.01 - 100 $\frac{\text{N}}{\text{m}}$ stiffness
- 10-500 kHz resonance freq.
- Conical or pyramidal tip
- 2-50 nm radius of curvature of tip apex

Modes:

- contact
- friction
- resonant
- tapping

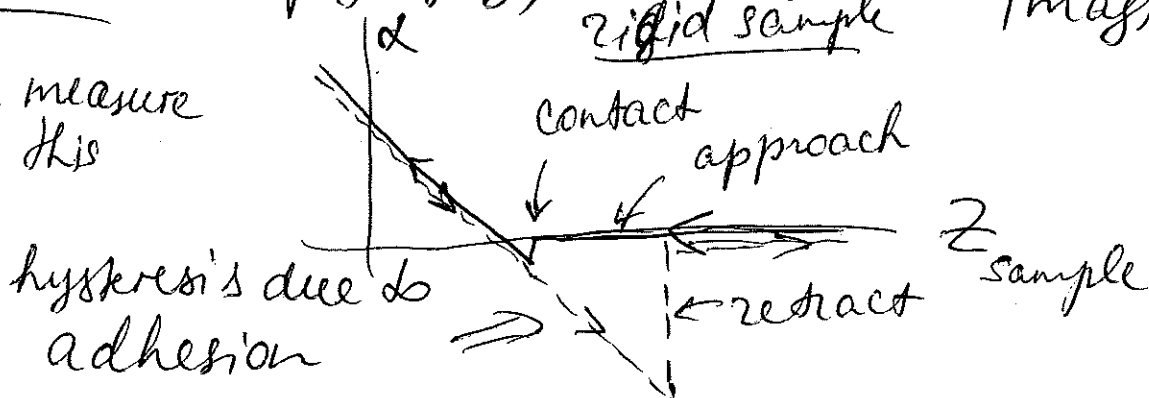
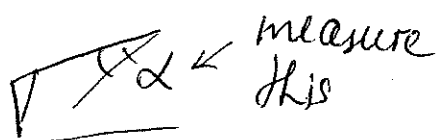
interaction force between tip & sample

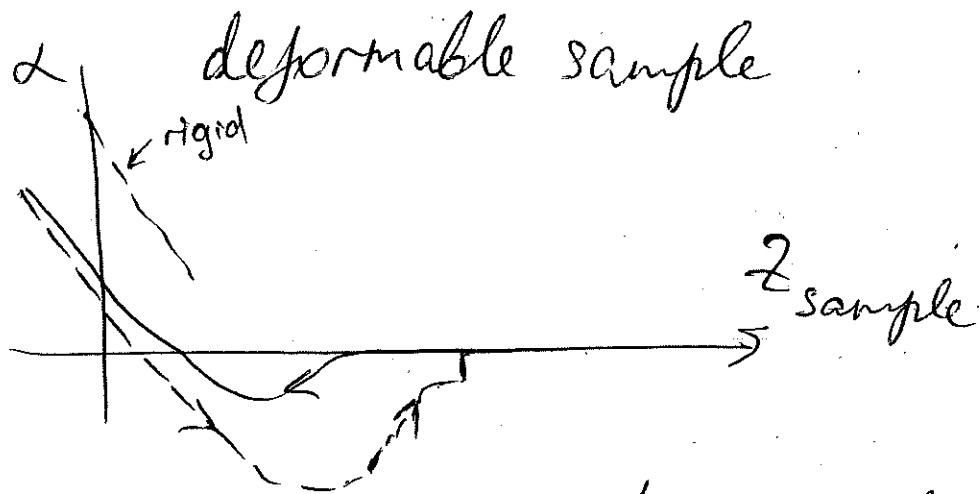
F



Resolution $\rightarrow$ depends on the tip shape & size

Contact mode: topography, elasticity & adhesion imaging.





Resonant mode:

• drive cantilever ^{at} ~~with~~ a fixed frequency close to resonance

AM - AFM $\Leftarrow$ and follow variations in amplitude & phase. Sample height is servo-controlled at a constant amplitude. Used in air.

• Dynamic mode - phase-locked loop which holds vibration amplitude & phase difference at certain values. Self-oscillations & their resonant freq. are monitored.

$\Rightarrow$ FM - AFM
freq. modulated

Typically used in UHV

General problem: find vibrational modes of a beam (cantilever) clamped at one end and subjected to a force field at the other. In a simple, one-mode, case $\Rightarrow$

$$\ddot{X} + 2\beta\dot{X} + \omega_0^2 X = f \cos \omega t + \frac{f(D, t)}{m}$$

displacement of tip from equilibrium

(3)

ω_0 - resonant frequency
 $\sqrt{\frac{k}{m}}$

$Q = \frac{\omega_0}{2\beta}$
 $\uparrow$ quality factor $\uparrow$ dissipation

γ - amplitude of excitation at frequency ω

$\uparrow \sim 400$ in air

$\sim 10,000$ in VHV

~ 10 in water

$f(D, t)$ - tip-sample interaction $\Rightarrow$ if $f(D, t) = f(D+x) =$
 $\uparrow$ tip-sample separation when cantilever is not deflected $= f(D) + f'(D)x \Rightarrow$

$\ddot{x} + 2\beta\dot{x} + \left[\omega_0^2 - \frac{f'(D)}{m} \right] x = \gamma \cos \omega t + f_0$
 $\underbrace{\omega_0^2 - \frac{f'(D)}{m}}_{\sim \omega_0'^2} \leftarrow$ resonance shifts!

Tapping mode $\Rightarrow$ seek solution $x = A \cos(\omega t - \varphi)$

Energy dissipated by tip-sample interaction over one cycle

$$U_{\text{diss}} = \oint f(D, t) dx = A m \gamma \left(\frac{2A\beta\omega}{\gamma} - \sin\varphi \right)$$

If A is held constant when an image is scanned, the phase offset φ between excitation & oscillation of cantilever is a measure of U_{diss} .

Can do: elasticity measurements on a single molecule
 magnetic measurements, electrical $\Rightarrow$ EFM (e.s. image working transistors), KFM, SCM, etc.
 $\uparrow$ Kollision $\uparrow$ Scanning capacitance

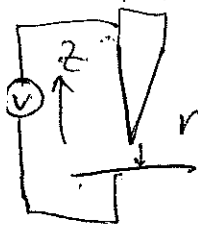
KFM $\Rightarrow$ apply voltage to the tip; (4)

$+ \sim V \sin \omega t$ Since applied force is capacitive, $F \sim V^2$
 $\Leftarrow$ Potential difference $= V + v \sin \omega t$

If cantilever is driven at $\omega \approx \frac{\omega_0}{2} \Rightarrow$
 can measure signal at ω_0 and determine V
 which includes applied voltage and electrical
 characteristics of the sample.

Scanning tunneling microscopy (STM)

Binnig & Rohrer (1982) $\Leftarrow$ Nobel Prize in Physics
 1986



measure tunneling
current

$$I \sim \frac{e^2 V}{h} \rho_s(r_0, E_F) \rho_t(E_F)$$

$\nearrow$ low V

$\nearrow$ Tersoff-Hamann theory

DOS at
the measured
surface at tip
position r_0

$\nearrow$ DOS of
the tip
at energy
 E_F

$$\psi(z) = \psi(0) e^{-Kz}$$

$$K = \sqrt{\frac{2m(V-E)}{\hbar^2}} = \sqrt{\frac{2m\phi}{\hbar^2}}$$

$$K \sim 1 \text{ \AA}^{-1} \Leftarrow \text{work function of metal}$$

high resolution in z !
 (W, Pt, Au, ~~Ag~~) $\sim 5 \text{ eV}$

$$I = \frac{2\pi}{h} e^2 V \sum_{nm} |M_{nm}|^2 \delta(E_n - E_F) \delta(E_m - E_F),$$

$$M_{nm} = \frac{\hbar}{2m} \int_S dS (\psi_n^\dagger \vec{\nabla} \psi_m - \psi_m \vec{\nabla} \psi_n^\dagger) \quad (5)$$

Low $V \Rightarrow$ Tersoff-Hamann theory - applicable to metals

For semiconductors $\Rightarrow$

$$I = \int_0^{eV} \rho_s(r_0, E) \rho_t(r_0, -eV + E) T(E, eV, r_0) dE \quad (V \sim 1V)$$

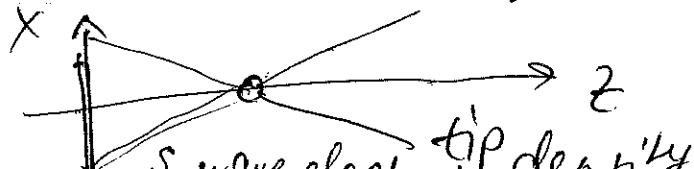
$$T(E, eV) = \exp \left[- \frac{2z\sqrt{m}}{\hbar} \sqrt{\frac{\phi_s + \phi_t}{2} + \frac{eV}{2} - E} \right]$$

↑
WKB

For $eV < 0$ (negatively polarized surface) $\Rightarrow$ have $T_{\max}$ at $E=0$, which corresponds to the electrons in the Fermi level of the surface. For $eV > 0$, $T_{\max}$ is at $E = eV \Rightarrow$ electrons in the Fermi level of the tip.

Resolution $\Rightarrow$ depends on the tip & sample states $\Rightarrow$ assume that there is only one atom at the very end of the tip which participates in the tunnel current.

Assume s-type wave $|\psi|^2 \sim \frac{e^{-2Kr}}{r^2}$, $r = \sqrt{x^2 + z^2}$



$$\text{At } z \gg x \Rightarrow |\psi|^2 \approx \frac{e^{-2Kz}}{z^2} e^{-\frac{Kx^2}{z}} \quad (6)$$

FWHM of the Gaussian is $\Delta x = \sqrt{\frac{2z}{K}}$ $\Rightarrow$

If $K \approx 1 \text{ \AA}^{-1}$ and z in $\text{\AA}$, $\Delta x \sim 1.4 \sqrt{z} \text{ \AA}$
 order of magnitude of the spatial resolution

In the Tersoff-Hamman theory, $z = d + R$
 The best resolution $\Rightarrow$ Sub-pm vertical
sub- $\text{\AA}$ lateral
 $\sim 1.4 \sqrt{R} \text{ \AA}$
 tip-sample distance
 radius of curvature of the tip apex
 how small a feature can STM distinguish

$\nwarrow$ This is not known accurately though

Contrast $\Delta z \approx \frac{2}{K} e^{-2z(\sqrt{K^2 + \frac{\pi^2}{a^2}} - K)}$
 how different the signal between two inequivalent positions
 For large lattice periods, i.e. $a \gg \frac{\pi}{K}$
 high, almost z -independent contrast
 large contrast = large DOS $\Rightarrow$ difference

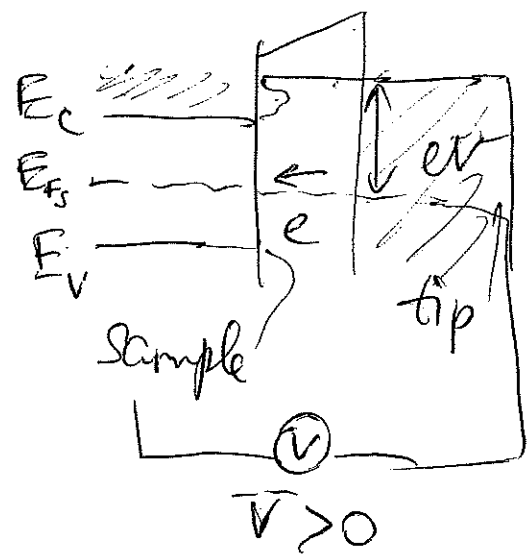
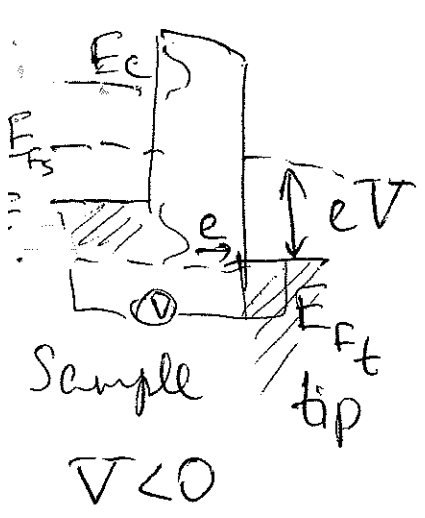
E.g. for $\Phi = 4 \text{ eV}$, $\Delta z \approx 1.6 \text{ \AA}$ at $a = 12 \text{ \AA}$

If $a < \frac{\pi}{K} \Rightarrow \Delta z \rightarrow e^{-\frac{\pi^2 z}{a^2 K}}$
 exp decrease with tip-sample distance

STM spectroscopy

hold tip fixed above the surface; measure $I(V) \Rightarrow$
 get electronic structure of the surface at diff. energies

⑦



Generally, need V_{HV} and $< 10k$

Elastic current $\Leftrightarrow$ electrons do not interact with surface $\Rightarrow$ their energy is const.

no coupling
electron-phonon

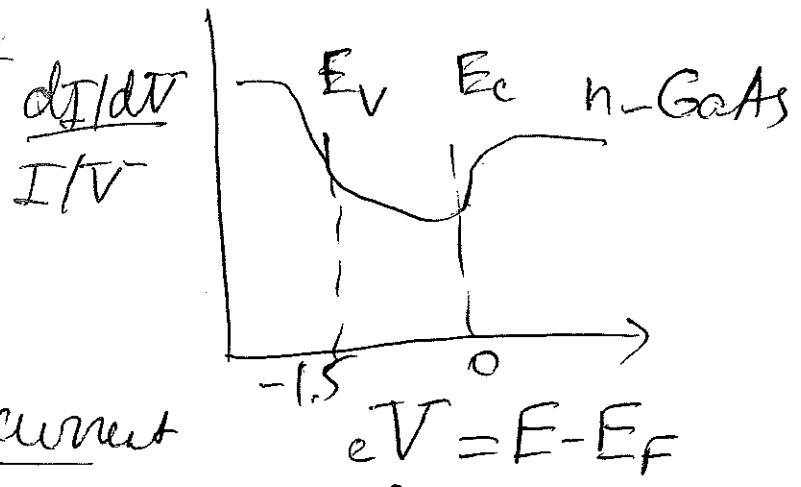
In metals, $T(V) \sim aV \Rightarrow \frac{dI}{dV} \sim \rho_s(E)$

$$\frac{dI/dV}{I/V} = \frac{\rho_s(E)}{\frac{1}{eV} \int_0^{eV} \rho_s(E) dE}$$

tip-sample distance at bias

For $V < \Phi \Rightarrow Z(V) = Z_0 \left(1 + \frac{|V|}{4\Phi} \right)$

Example



$T(V) = e^{-\frac{2\sqrt{\Phi}}{\sqrt{\Phi - V}}}$

max keep const

$Z \sqrt{1 - \frac{|V|}{2\Phi}} = Z_0$

done on single molecules

Inelastic current

$\Rightarrow \frac{d^2I}{dV^2} \Rightarrow$ let for sample voltage

vibrational energy of a single bond

